

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/562,400 Confirmation No. : 8481
First Named Inventor : Hiroshi Kannan
Filed : April 25, 2006
TC/A.U. : 1792
Examiner : Mahmoud Dahimene
Docket No. : 010986.57272US
Customer No. : 23911
Title : PLASMA GENERATION METHOD, CLEANING
METHOD, AND SUBSTRATE PROCESSING METHOD

REPLY TO OFFICE ACTION

Mail Stop AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are respectfully submitted in response to the non-final Office Action mailed April 2, 2009.

Amendments to the Specification are provided on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks begin on page 22 of this paper.